

DIRECTOR, U.S. PATENT AND TRADEMARK OFFICE WASHINGTON, DC 20231

In re Application of:				RAYNOR ET AL.								
Serial No.:				Not yet assigned								
Filed:				Herewith	1							
For:				SOLID S	TATE	IMAG	SING	DEV	CE	•		
Sir:												
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2.	[]		This IDS is su amount of \$ <u>1</u>		under (37 C.	F.R. §	§ 1.97	7 (c).	Enclo	se	ed is a check in the
3.	[]		This IDS is su	ıbmitted ι	under (37 C.I	F.R. §	§ 1.97	7(c) a	ınd (e).	No fee is required.
4.	[]		This IDS is su in the amount	ıbmitted ı t of <u>\$130.</u>	under (<u>00</u> to c	37 C.I	F.R. § the p	§ 1.97 etitio	'(d) a	and (e).	Enclosed is a check
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INFORMATION DISCLOSURE STATEMENT

Atty Docket: Serial No.: Applicant: Filing Date: Group: 00ED18852609 Not Yet Assigned RAYNOR ET AL. Herewith

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EXAMINER:	DATE CONSIDERED:					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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